## **Supporting Information**

## **Electronic Structures and Transport Properties of MoS2-NbS2**

## Nanoribbon Lateral Heterostructure

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Fig.S1 Band structures of armchair  $MoS_2$  nanoribbons (AMoS<sub>2</sub>NRs) with the nanoribbon width( $N_A$ ) varying from 3 to 18. The red dash dot lines indicate the Fermi levels. Green regions indicate the forbidden bands below the Fermi level.



Fig.S2 Band structures of armchair NbS<sub>2</sub> nanoribbons (ANbS<sub>2</sub>NRs) with the nanoribbon width( $N_A$ ) varying from 3 to 18. The red dash dot lines indicate the Fermi levels. Green regions indicate the forbidden bands below the Fermi level.



Fig.S3 (a) Density of states(DOS) of ANbS<sub>2</sub>NR with  $N_A$ =3, indicating a bandgap of 21 meV. (b)Band structure of ANbS<sub>2</sub>NR with  $N_A$ =5, calculated using a supercell of two primitive cell. (c)Band structure of ANbS<sub>2</sub>NR with  $N_A$ =5, calculated using a primitive cell.



Fig.S4 Electrostatic potential in the direction perpendicular to the nanoribbon or monolayer surface (x direction). The value of electrostatic potential at the position far apart the surface is used as the vacuum level to calculate the work function. The example is an ANbS<sub>2</sub>NR of  $N_A$ =3.



Fig.S5. The change( $\Delta N$ ) in the number of electrons as a function of Vg in the channel of AMoS<sub>2</sub>NR -ANbS<sub>2</sub>NR field effect transistor. The V<sub>bias</sub> is set to be 0 V. Owning to the seamless contact, the electrostatic potential of channel (V<sub>c</sub>) is also 0 V. With a capacitive circuit model<sup>1</sup>, the gate oxide capacitance (C<sub>G</sub>) is calculated to be 2.26X10<sup>-19</sup>F, which is close to the result of 2.32X10<sup>-19</sup>F from  $\varepsilon S/d$ , where S is the size of channel and d is the thickness of dielectric region.



Fig.S6 Transfer characteristics of AMoS<sub>2</sub>NR -ANbS<sub>2</sub>NR field effect transistor with  $V_{\text{bias}}$ =-0.02 V and  $V_{\text{bias}}$ =-0.30 V.  $V_{\text{bias}}$ =-0.30 V is in the saturation region of transport characteristics. The saturation currents are proportional to  $V_{\text{g}}$ .

1. Datta, S., *Quantum Transport Atom to Transistor*. Cambridge University Press: United States of America by Cambridge University Press, New York, 2005.